



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**Applicant:** Qi Xiang


**Title:** SILICON ON INSULATOR SUBSTRATE  
HAVING IMPROVED THERMAL  
CONDUCTIVITY AND METHOD OF ITS  
FORMATION

**Application No.:** 10/658,668

**Filing Date:** 9 September 2003

**Examiner:** H. TRINH

**Art Unit:** 2814

<b>CERTIFICATE OF EXPRESS MAILING</b>	
I hereby certify that this correspondence is being deposited with the United States Postal Service's "Express Mail Post Office To Addressee" service under 37 C.F.R. § 1.10 on the date indicated below and is addressed to: Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.	
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Ruthie Vallejo (Printed Name)	
 (Signature)	

**REPLY TO OFFICIAL ACTION OF 1 JUNE 2005**  
**UNDER 37 CFR §1.116**

Mail Stop AF  
Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicant hereby replies to the official action mailed 1 June 2005.

Reconsideration in view of the following amendments and remarks is requested.